

STATEMENT UNDER 37 CFR 3.73(b)

Atty. Docket No. 1857.6780001

Applicant/Patent Owner: GURER et al.

Application No./Patent No.: 6,955,720 Filed/Issue Date: October 18, 2005

Entitled: Plasma Deposition of Spin Chucks to Reduce Contamination of Silicon Wafers

ASML Holding N.V., a

corporation

(Name of Assignee)

(Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)

states that it is:

1. ☒ the assignee of the entire right, title, and interest; or
2. ☐ an assignee of less than the entire right, title and interest
(The extent (by percentage) of its ownership interest is _____ %)

in the patent application/patent identified above by virtue of either:

- A. ☐ An assignment from the inventor(s) of the patent application/patent identified above. The assignment was recorded in the United States Patent and Trademark Office at Reel _____, Frame _____, or for which a copy therefore is attached.

OR

- B. ☒ A chain of title from the inventor(s), of the patent application/patent identified above, to the current assignee as follows:

1. From: GURER et al. To: Silicon Valley Group, Inc.

The document was recorded in the United States Patent and Trademark Office at
Reel 011882, Frame 0042, or for which a copy thereof is attached.

2. From: Silicon Valley Group, Inc. To: ASML US, Inc.

The document was recorded in the United States Patent and Trademark Office at
Reel 021360, Frame 0168, or for which a copy thereof is attached.

3. From: SVG Lithography Systems, Inc. To: ASML US, LLC

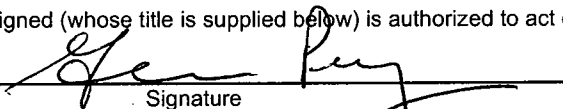
The document was recorded in the United States Patent and Trademark Office at
Reel 021360, Frame 0189, or for which a copy thereof is attached.

☒ Additional documents in the chain of title are listed on a supplemental sheet.

☒ As required by 37 CFR 3.73(b)(1)(i), the documentary evidence of the chain of title from the original owner to the assignee was, or concurrently is being, submitted for recordation pursuant to 37 CFR 3.11.

[NOTE: A separate copy (i.e., a true copy of the original assignment document(s)) must be submitted to Assignment Division in accordance with 37 CFR Part 3, to record the assignment in the records of the USPTO. See MPEP 302.08]

The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.


Signature

Glenn J. Perry, Reg. No. 28,458
Printed or Typed Name

Authorized Agent

Title

December 9, 2008

Date

(202) 371-2600

Telephone Number

**Statement Under 37 CFR 3.73(b) (PTO/SB/96)
Supplemental Sheet for Chain of Title, Item B**

Applicant/Owner: GURER et al.

Application No./Patent No.: 6,955,720

Application Date/Issue Date: October 18, 2005

Title: **Plasma Deposition of Spin Chucks to Reduce Contamination of Silicon Wafers**

Name of Assignee: **ASML Holding N.V.**

Type of Assignee: **corporation**

Part B Continued: Additional Documents in the Chain of Title

4. From: ASML US, Inc. To: ASML US, LLC
The document was recorded in the United States Patent and Trademark Office at
Reel 021360, Frame 0088, or for which a copy thereof is
attached.
5. From: ASML US, LLC To: ASML US, Inc.
The document was recorded in the United States Patent and Trademark Office at
Reel 021360, Frame 0092, or for which a copy thereof is
attached.
6. From: ASML US, Inc. To: ASML Holding N.V.
The document was recorded in the United States Patent and Trademark Office at
Reel 021938, Frame 0962, or for which a copy thereof is
attached.
7. From: _____ To: _____
The document was recorded in the United States Patent and Trademark Office at
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